Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination	·
10/580,451	KOHEN, RAN	
Examiner	Art Unit	
Hae M. Hyeon	2839	

SEARCHED			
Class	Subclass	Date	Examiner
Search	Updated	8/07	hmh
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
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